

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>	Docket number (Optional)	Application Number
	15689.73	09/889,000
	Applicant(s)	
	Shinji Uebayashi, et al.	
	Filing Date	Group Art Unit
	6/22/2001	2616

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
	1	2000-175244	6/23/2000	Japan	H04Q7	22	X	
	2	2000-092570	3/31/2000	Japan	H04Q7	38	X	
	3	09-205673	8/5/1997	Japan	H04Q7	34	X	
	4	09-200826	7/31/1997	Japan	H04Q7	22	X	
	5	09-116458	5/2/1997	Japan	H04B1	50	X	
	6	05-252098	9/28/1993	Japan	H04B7	26	X	

EXAMINER	DATE CONSIDERED
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*Examiner Initial	OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
	7	Official Notice of Rejection; Case No.: DCMH120076; Patent Application No.: 2000-190173
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